

Serial No.: 10/765,366
Response filed September 25, 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: SUN-HEE KIM, ET AL.
Serial No.: 10/765,366
Conf. No.: 1569
Filed: January 27, 2004
Title: METHOD OF TREATING SURFACE OF SUBSTRATE USED IN
BIOLOGICAL REACTION SYSTEM
Examiner: BERTAGNA, Angela Marie
Art Unit: 1641
Docket No: YPL-0073

VIA EFS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO RESTRICTION REQUIREMENT

This Response is responsive to the Restriction Requirement mailed August 29, 2006.